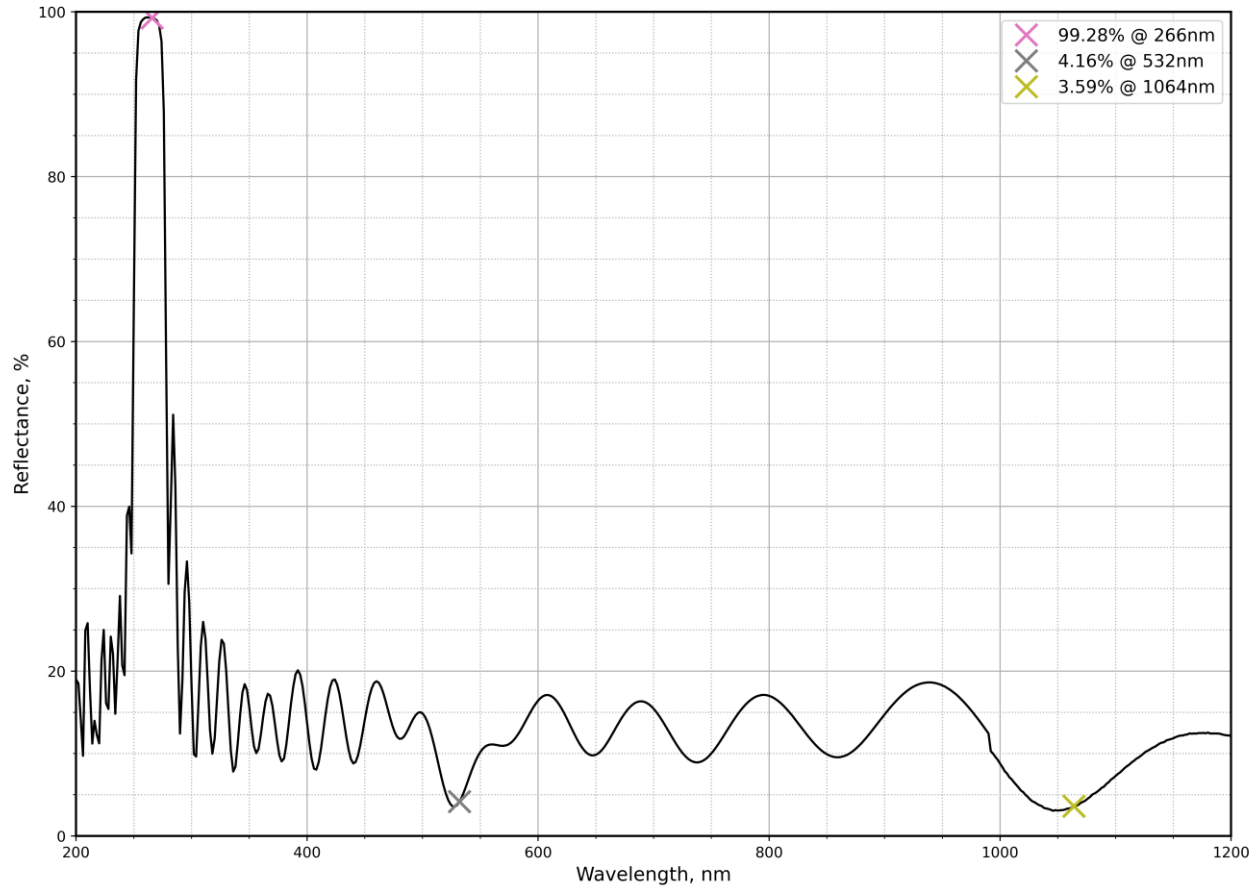


S1: (arrow marks) HRs > 99.5% @ 266 nm + Rp<2%; Rs<10% @ 532 nm + Rp<2%; Rs<10% @ 1064 nm, AOI 45 deg.  
S2: Uncoated



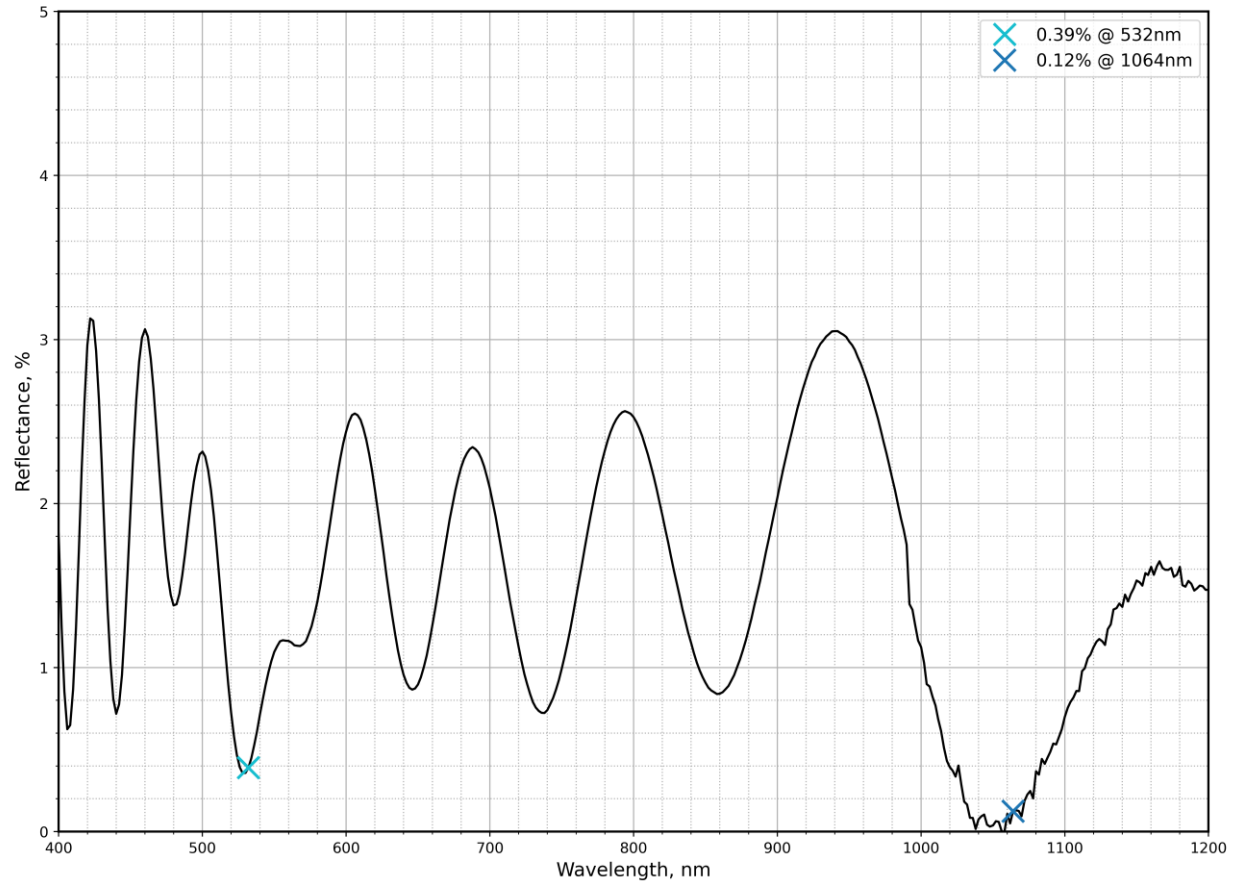
PO2636 Rs i45 S1 (1 samples)

Fig. 1.

SIDE MEASURED: S1+S2 (good component)

COMMENTS: Margin of measurement error: +/-0.25%

S1: (arrow marks) HRs > 99.5% @ 266 nm + Rp<2%; Rs<10% @ 532 nm + Rp<2%; Rs<10% @ 1064 nm, AOI 45 deg.  
S2: Uncoated

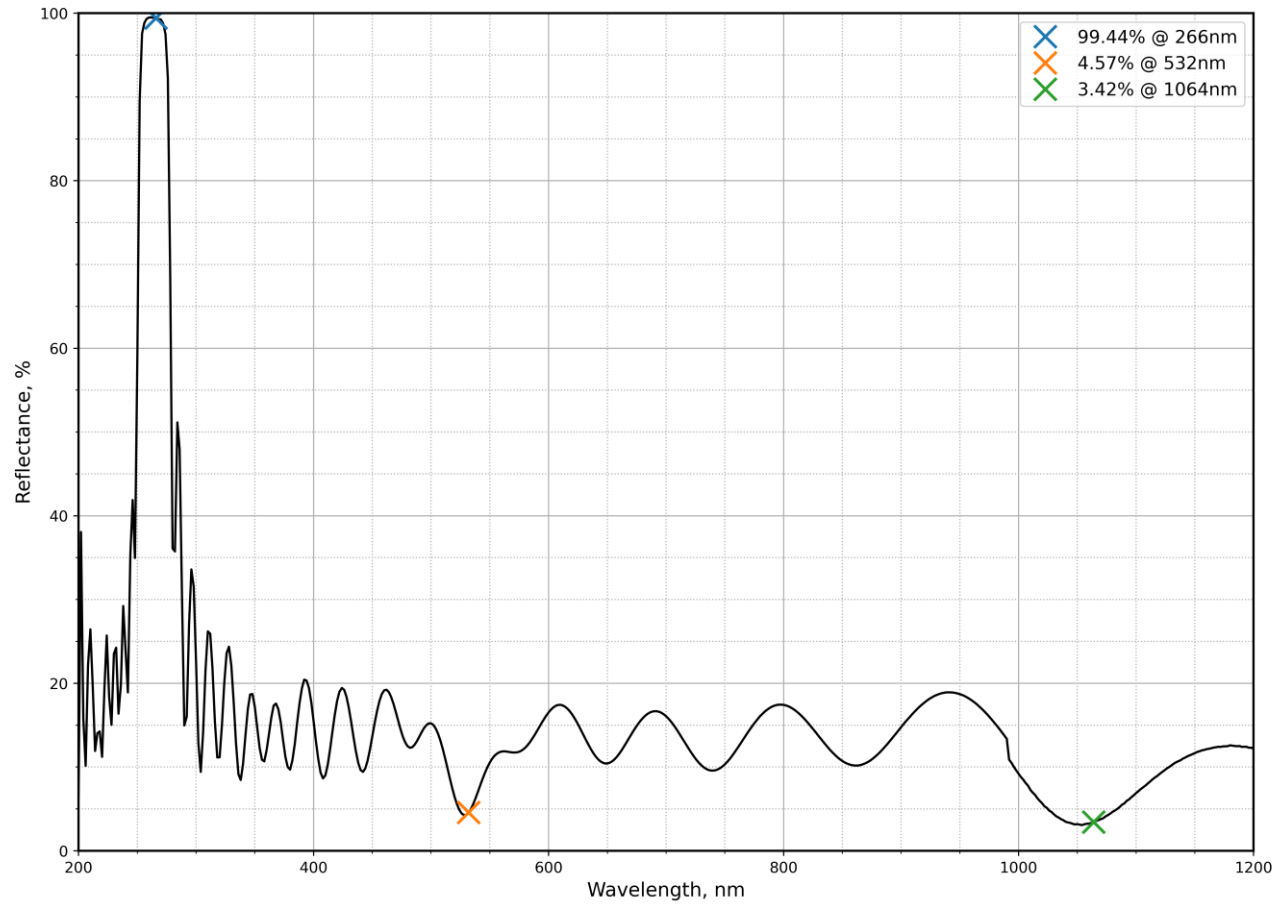


PO2636 Rp i45 S1 (1 samples)

Fig. 2.

SIDE MEASURED: S1+S2 (good component)  
COMMENTS:

S1: (arrow marks) HRs > 99.5% @ 266 nm + Rp<2%; Rs<10% @ 532 nm + Rp<2%; Rs<10% @ 1064 nm, AOI 45 deg.  
S2: Uncoated



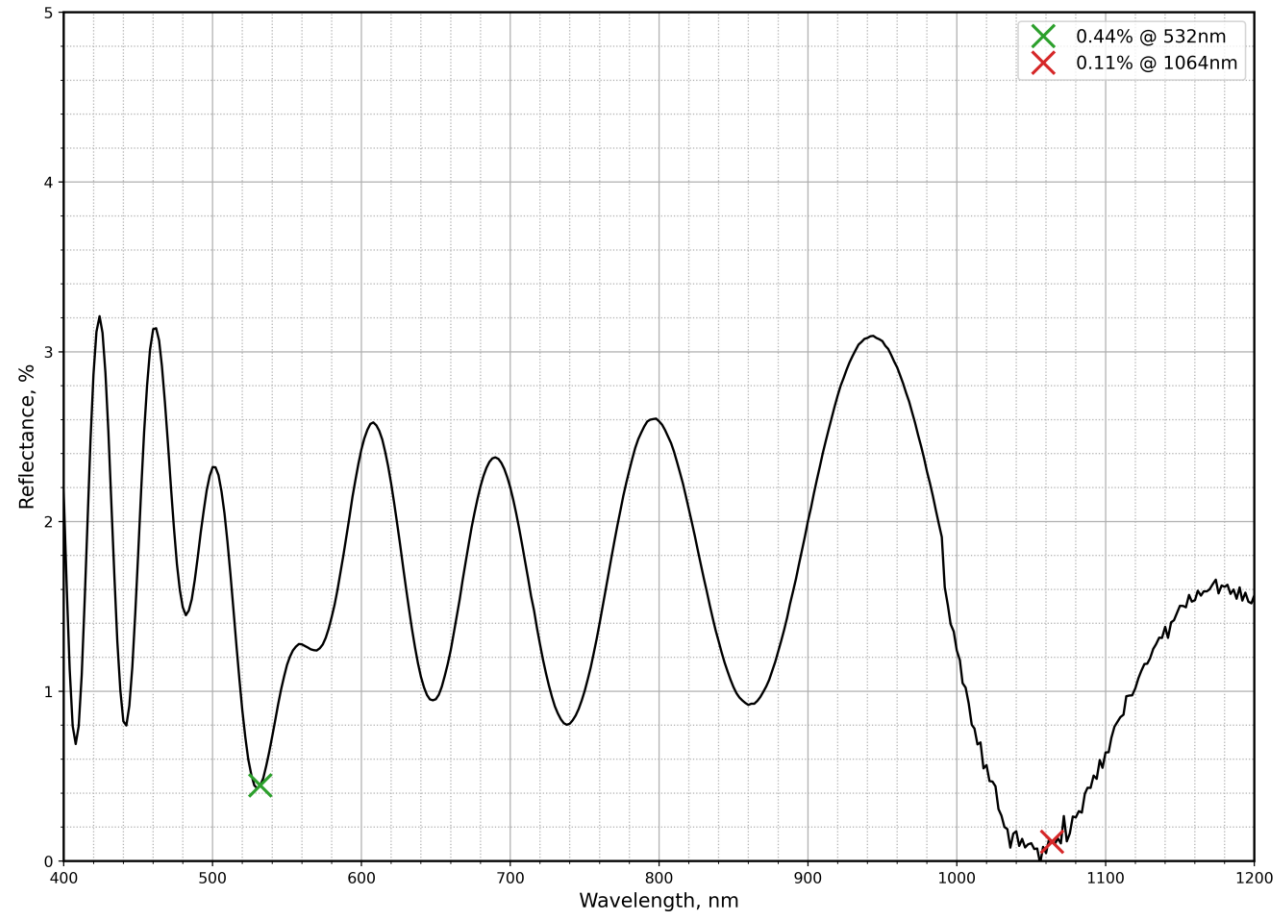
PO2636 Rs i45 S1 (2 samples)

Fig. 3.

SIDE MEASURED: S1+S2 (good component)

COMMENTS: Margin of measurement error: +/-0.25%

S1: (arrow marks) HRs > 99.5% @ 266 nm + Rp<2%; Rs<10% @ 532 nm + Rp<2%; Rs<10% @ 1064 nm, AOI 45 deg.  
S2: Uncoated



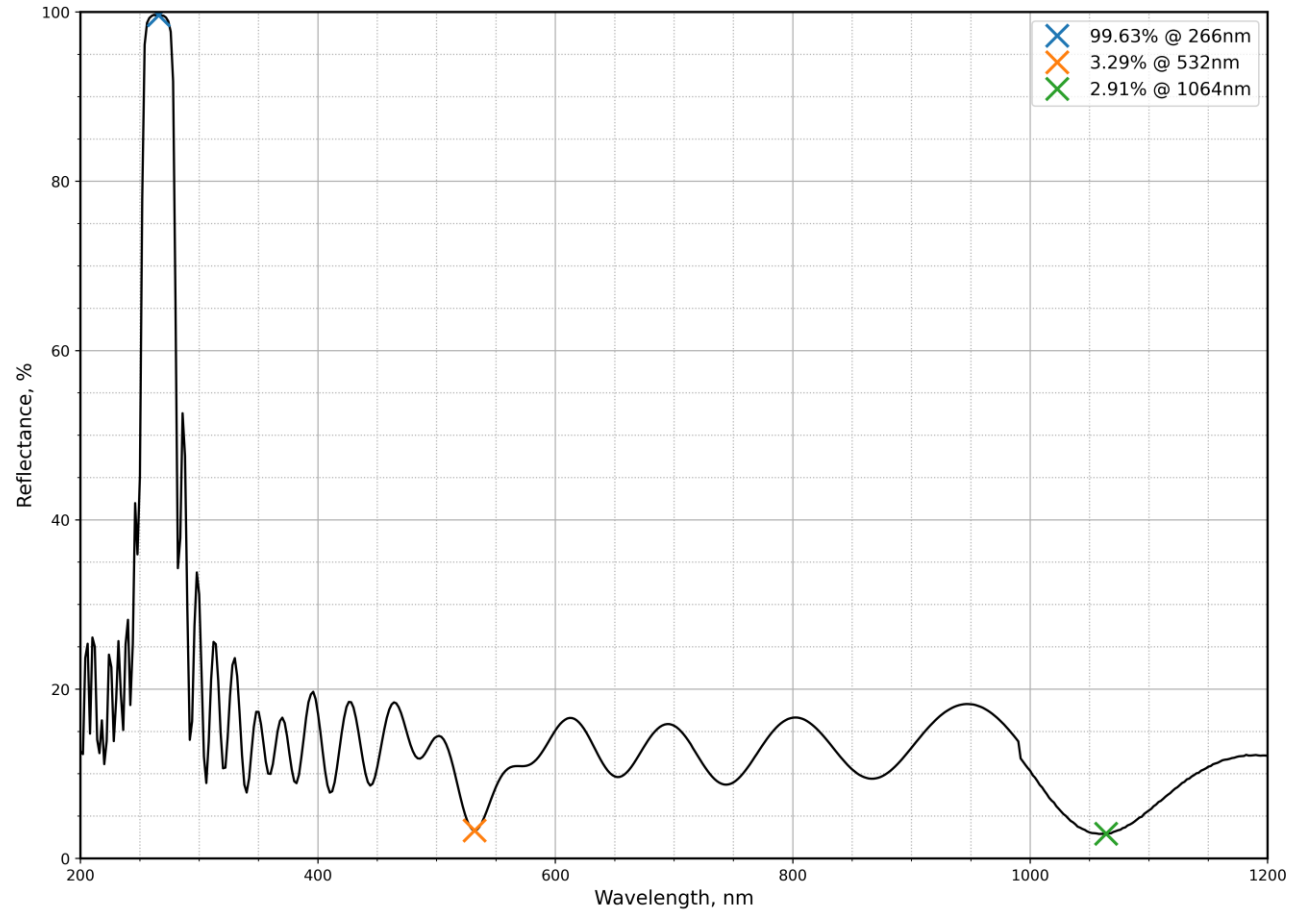
PO2636 Rp i45 S1 (2 samples)

Fig. 4.

SIDE MEASURED: S1+S2 (good component)

COMMENTS:

S1: (arrow marks) HRs > 99.5% @ 266 nm + Rp<2%; Rs<10% @ 532 nm + Rp<2%; Rs<10% @ 1064 nm, AOI 45 deg.  
S2: Uncoated



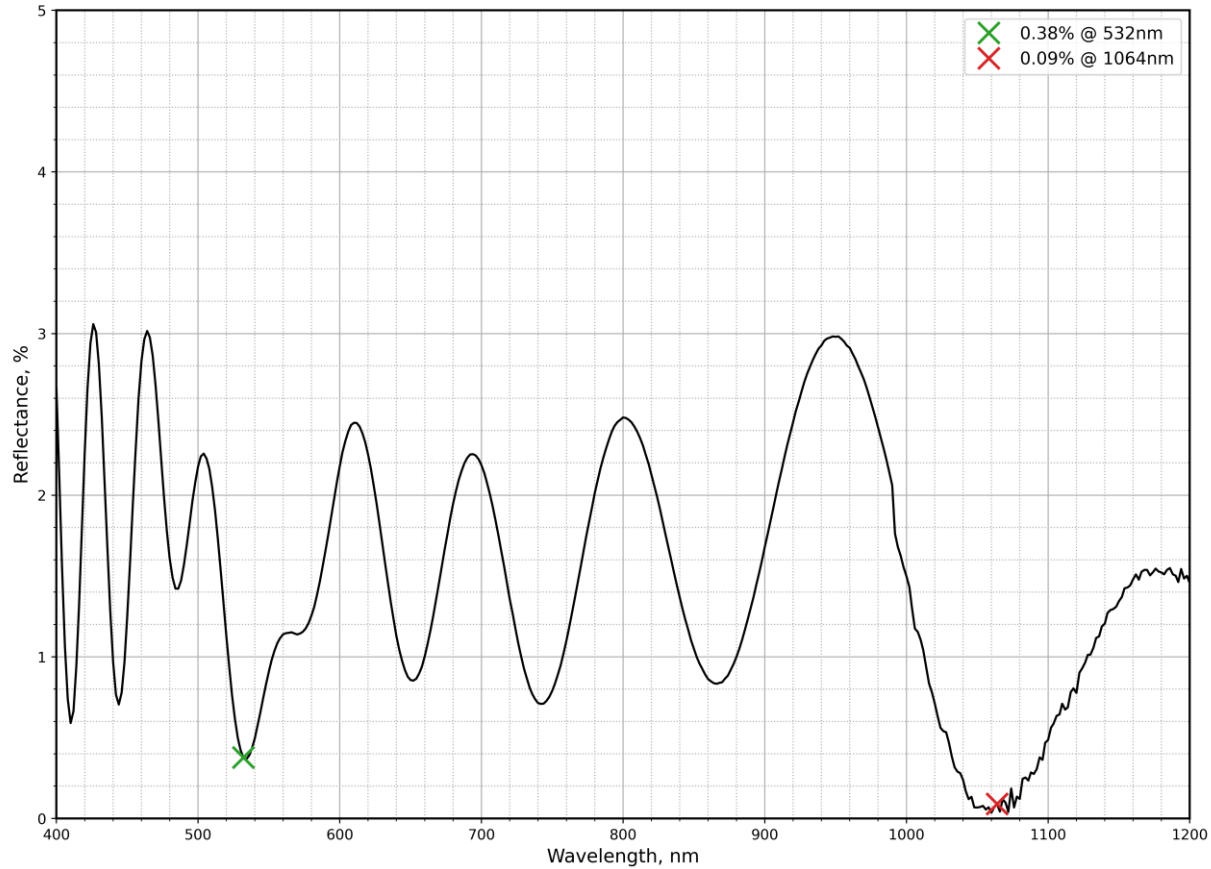
P02636 Rs i45 S1 (3 samples)

Fig. 5.

SIDE MEASURED: S1+S2 (good component)

COMMENTS:

S1: (arrow marks) HRs > 99.5% @ 266 nm + Rp<2%; Rs<10% @ 532 nm + Rp<2%; Rs<10% @ 1064 nm, AOI 45 deg.  
S2: Uncoated



PO2636 Rp i45 S1 (3 samples)

Fig. 6.

SIDE MEASURED: S1+S2 (good component)  
COMMENTS: